

Notice of References Cited	Application/Control No. 10/812,075	Applicant(s)/Patent Under Reexamination SEKIGUCHI ET AL.	
	Examiner Cecilia M. Jaisle	Art Unit 1624	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-5,691,321	11-1997	Schaper et al.	514/63
	B	US-			
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	J	US-			
	K	US-			
	L	US-			
	M	US-			

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	P	WO 1999/31072	06-1999	WIPO	Lee, et al.	
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	U	
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	W	
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